

# Analog IC Design

## Lecture 03 Review on Semiconductors Basics

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# Outline

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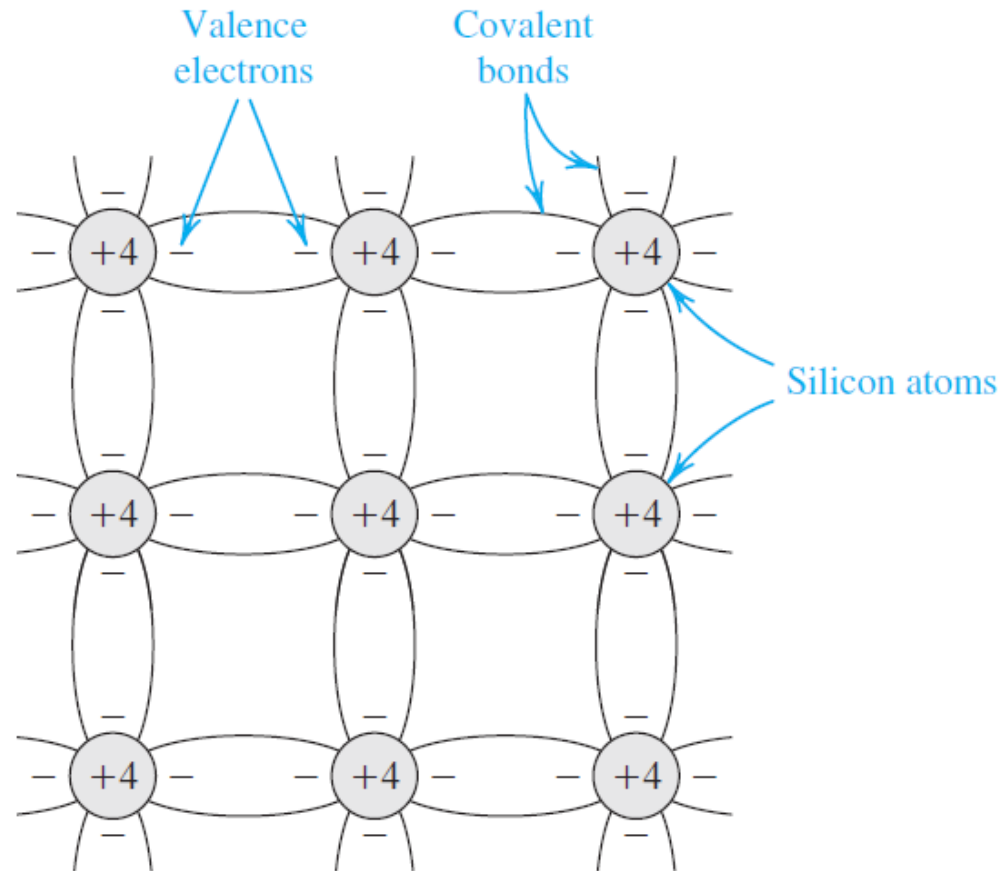
- ☐ What are semiconductors?
- ☐ Electrons and holes
- ☐ N-type and P-type silicon
- ☐ Drift and diffusion current
- ☐ The PN-junction

# What are Semiconductors

- ❑ Conductors → Ex: copper
- ❑ Insulators → Ex: glass
- ❑ Semiconductors are materials whose conductivity lies between that of conductors and insulators
- ❑ **What is so special about semiconductors?**
  - The electrical conductivity can be dramatically changed by introducing extrinsic dopant atoms
  - We have two types of carriers: electrons and holes
- ❑ Silicon (Si) is the semiconductor material used in the majority of today's electronic devices

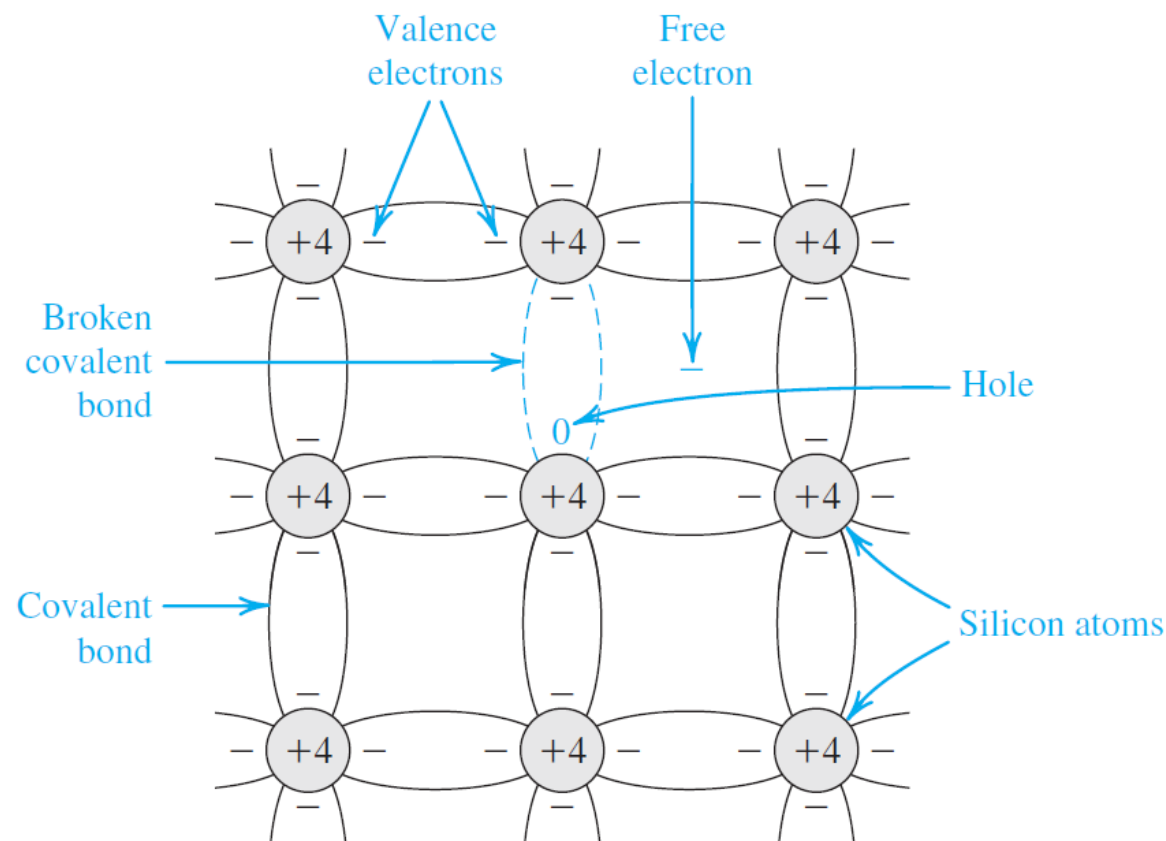
# Silicon Crystal

- ❑ Covalent bonds are formed by sharing of the valence electrons
- ❑ At 0 K, all bonds are intact and no free electrons are available



# Electrons and Holes

- ❑ At room temperature, some of the covalent bonds are broken by thermal generation
- ❑ Each broken bond gives rise to a free electron ( $e^-$ ) and a hole ( $h^+$ )
  - Both  $e^-$  and  $h^+$  become available for current conduction



# Intrinsic Silicon

- ❑ Carrier concentration is the number of charge carriers per unit volume ( $cm^3$ )
- ❑ At thermal equilibrium, the recombination rate is equal to the generation rate
- ❑ The concentration of free electrons ( $n$ ) is equal to the concentration of holes ( $p$ )

$$n = p = n_i$$

- ❑ The product of  $n$  and  $p$  is constant (depends only on temperature)

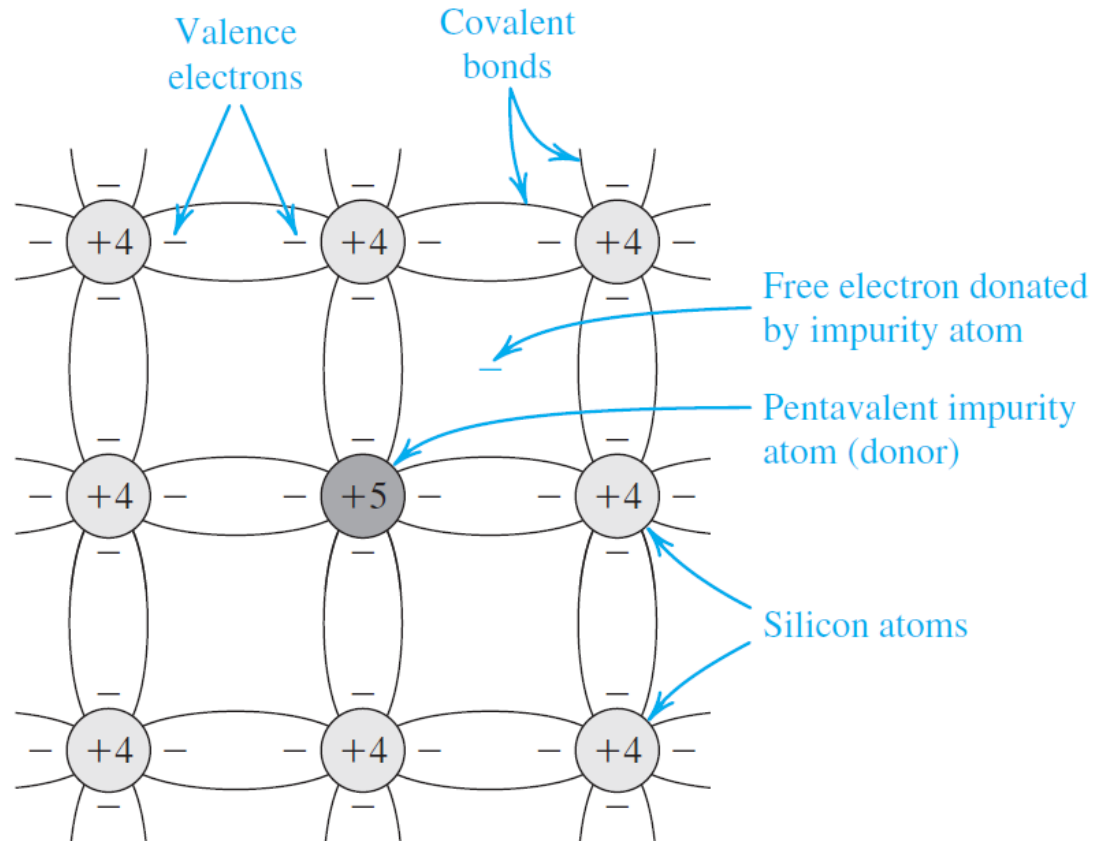
$$np = n_i^2$$

# Doped (Extrinsic) Silicon

- ❑ Doping involves introducing impurity atoms into the silicon crystal
- ❑ To increase the concentration of free electrons ( $n$ ) silicon is doped with a pentavalent (valence = 5) impurity (Ex: Phosphorus)
  - Each dopant atom (donor) gives a free  $e^-$  and a fixed positive charge (+ve ion)
  - Electrons become the majority carriers ( $n \gg p$ )
  - The doped silicon is **n-type**
- ❑ To increase the concentration of holes ( $p$ ) silicon is doped with a trivalent (valence = 3) impurity (Ex: Boron)
  - Each dopant atom (acceptor) gives a  $h^+$  and a fixed negative charge (-ve ion)
  - Holes become the majority carriers ( $p \gg n$ )
  - The doped silicon is **p-type**

# N-Type Silicon

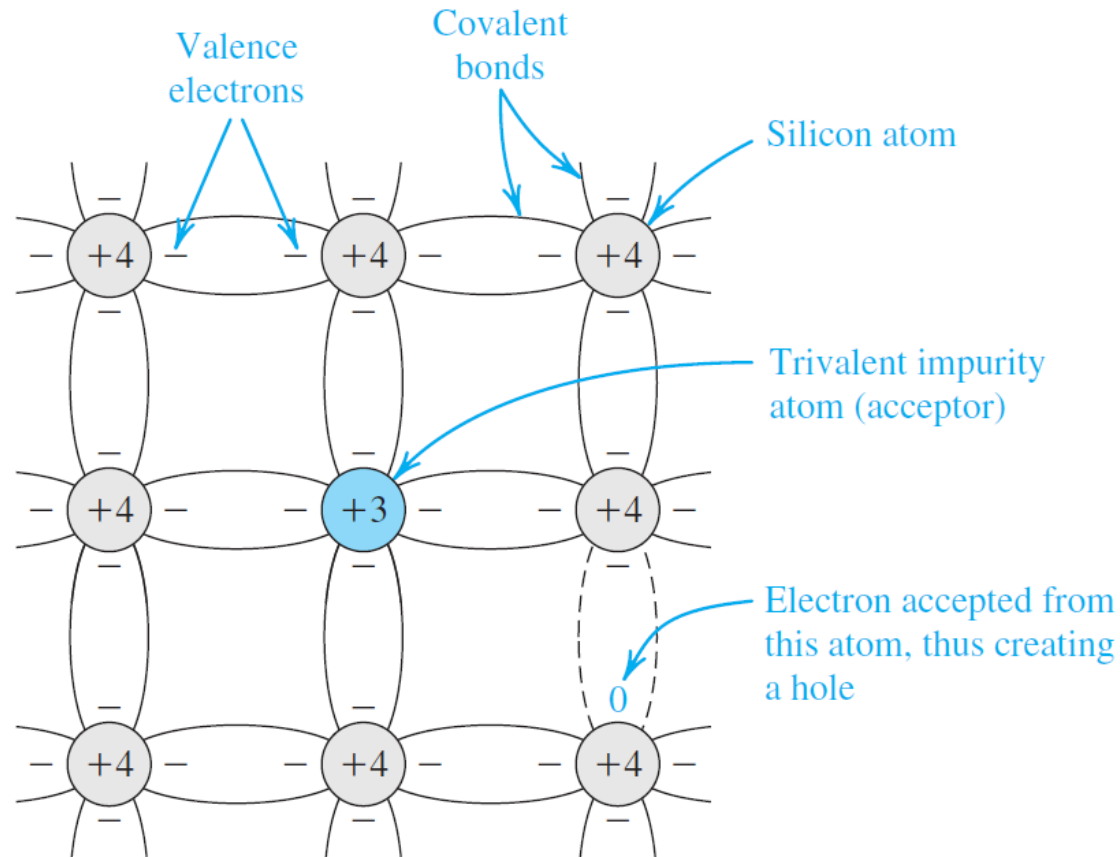
- ❑ Each dopant atom (donor) gives a free  $e^-$  and a fixed positive charge (+ve ion)
  - $N_D$ : donor concentration
- ❑ Electrons become the majority carriers ( $n \approx N_D \gg p$ )





# P-Type Silicon

- ❑ Each dopant atom (acceptor) gives a  $h^+$  and a fixed negative charge (-ve ion)
  - $N_A$ : acceptor concentration
- ❑ Holes become the majority carriers ( $p \approx N_A \gg n$ )



# Current Flow: (1) Drift Current

□ Current flows due to electrical field ( $E$ )

- Holes are accelerated in the direction of  $E$

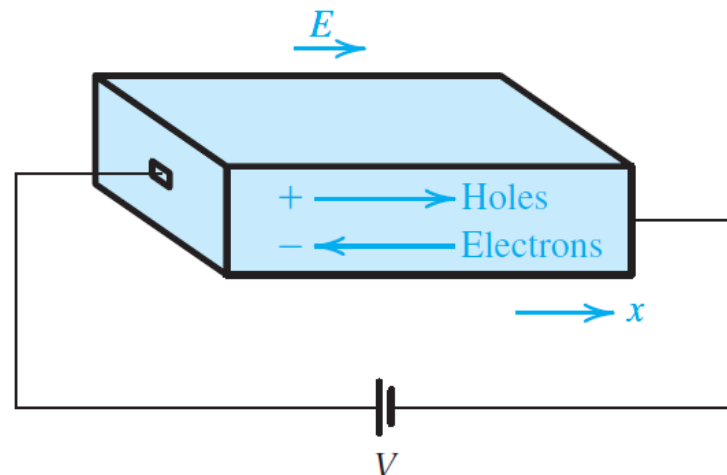
$$h^+ \text{ drift velocity} = v_{p\text{-drift}} = \mu_p E$$

- Free electrons are accelerated in the direction opposite to  $E$

$$e^- \text{ drift velocity} = v_{n\text{-drift}} = -\mu_n E$$

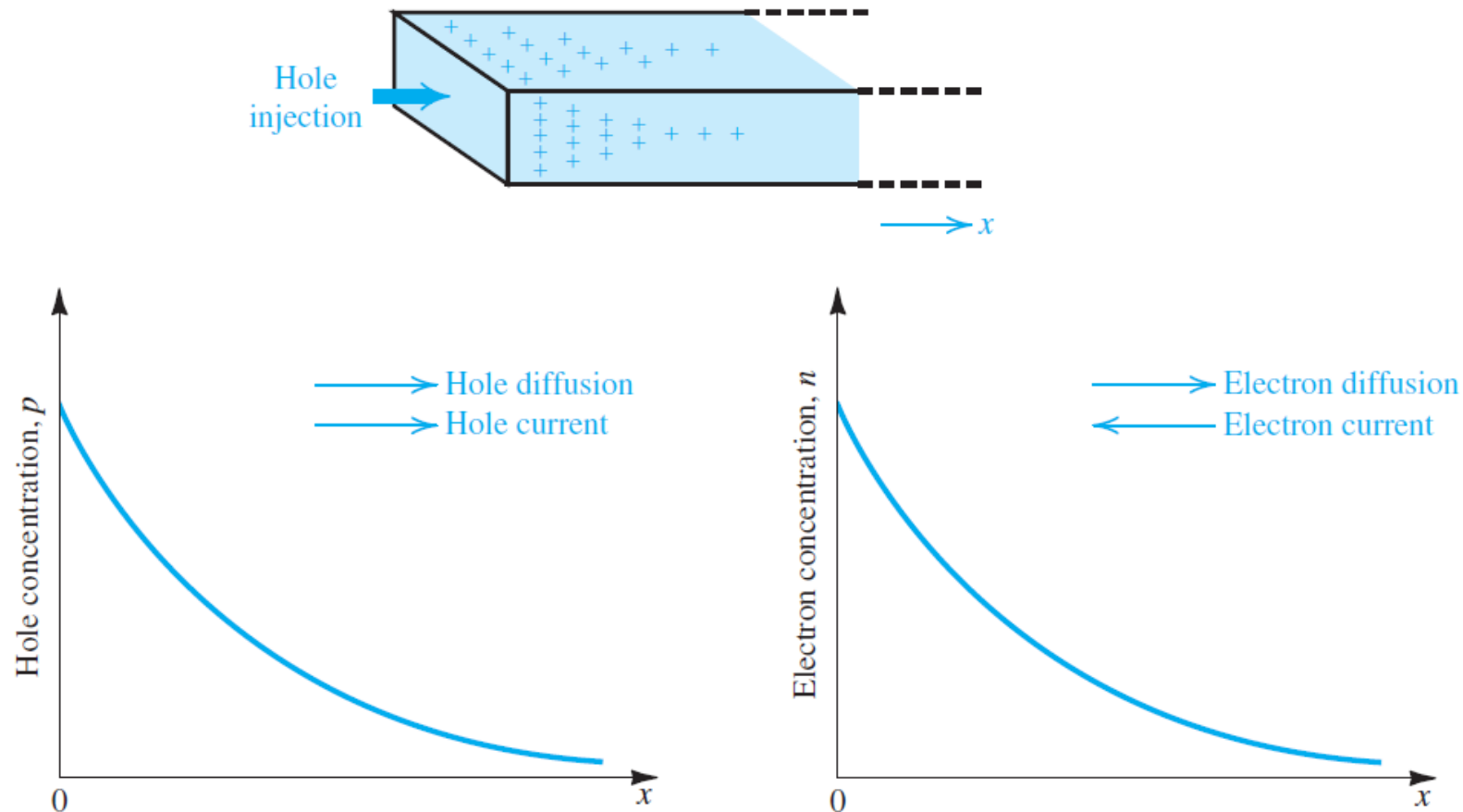
□  $\mu$  is the mobility:  $\mu_n = 2 - 4$  times  $\mu_p$

□ Note that if there are no carriers, there will be no current, even if there is an electric field

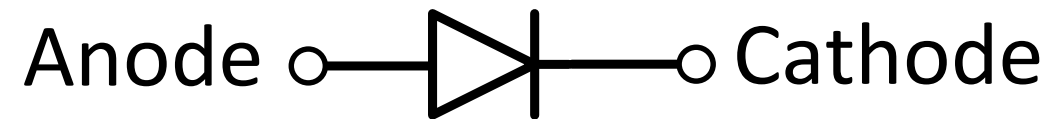
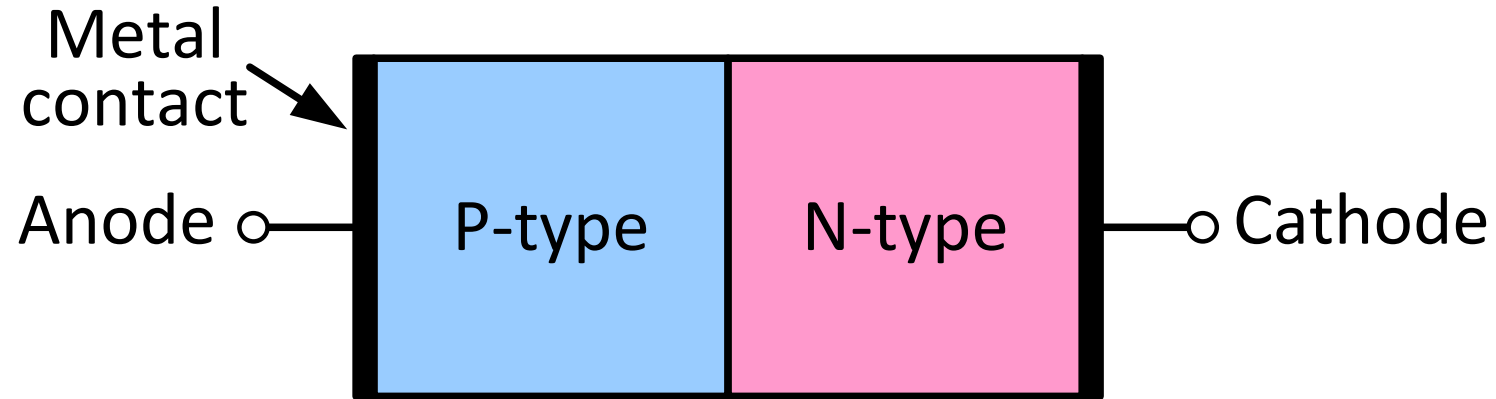


# Current Flow: (2) Diffusion Current

- Current flows due to carrier concentration gradient
  - Carriers diffuse from the region of high concentration to the region of low concentration

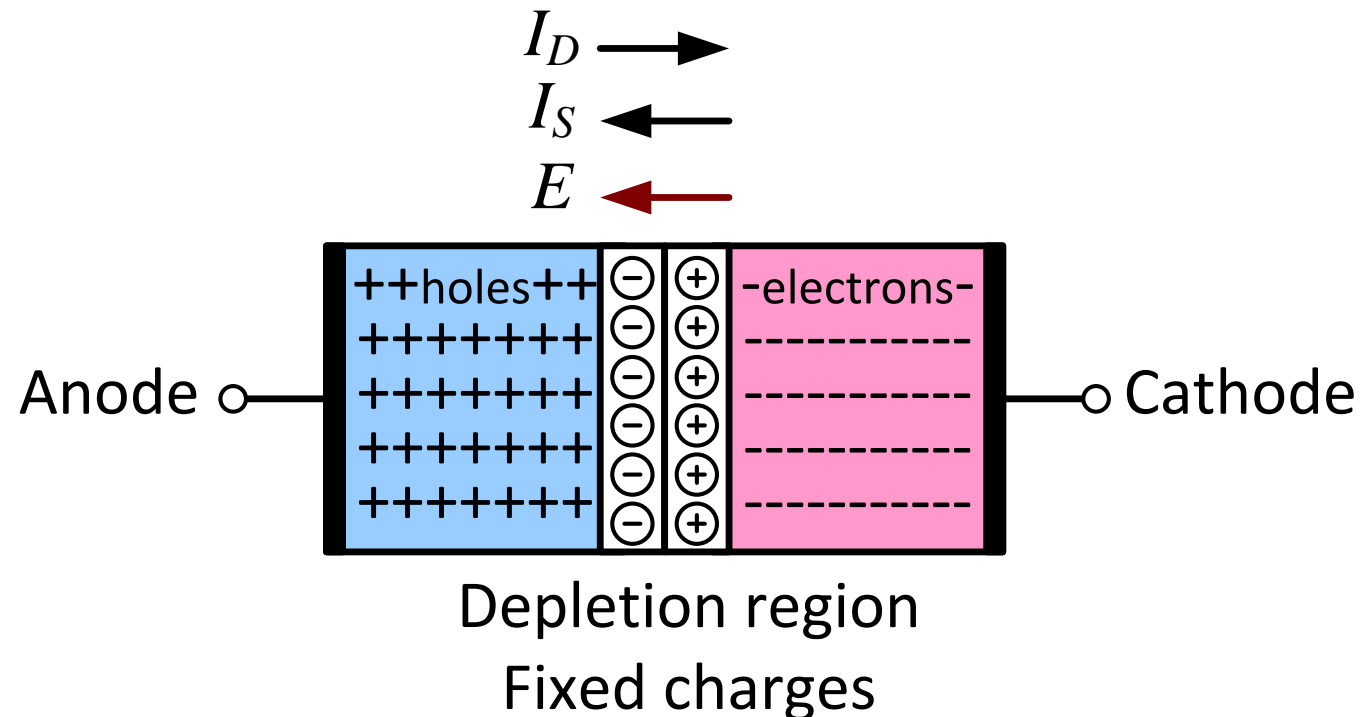


# The PN Junction (The Diode)



# PN Junction in Equilibrium (o.c.)

- Diffusion current ( $I_D$ ) flows due to concentration gradient
  - A depletion region of uncovered fixed charges is formed
  - The uncovered charges create  $E \rightarrow$  drift current ( $I_S$ )
- $I_D = I_S \rightarrow$  net current ( $I_D - I_S$ ) is zero
- Capacitance ( $C$ ) =  $\frac{\epsilon A}{d}$

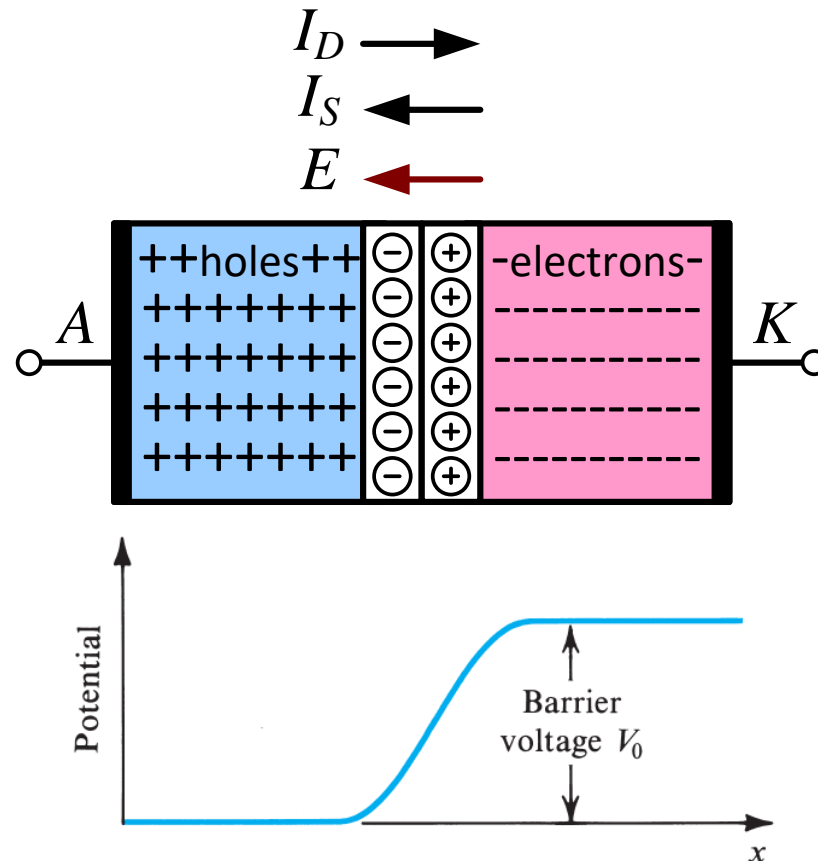


# PN Junction in Equilibrium (o.c.)

- Built-in electric field and barrier voltage due to depletion region

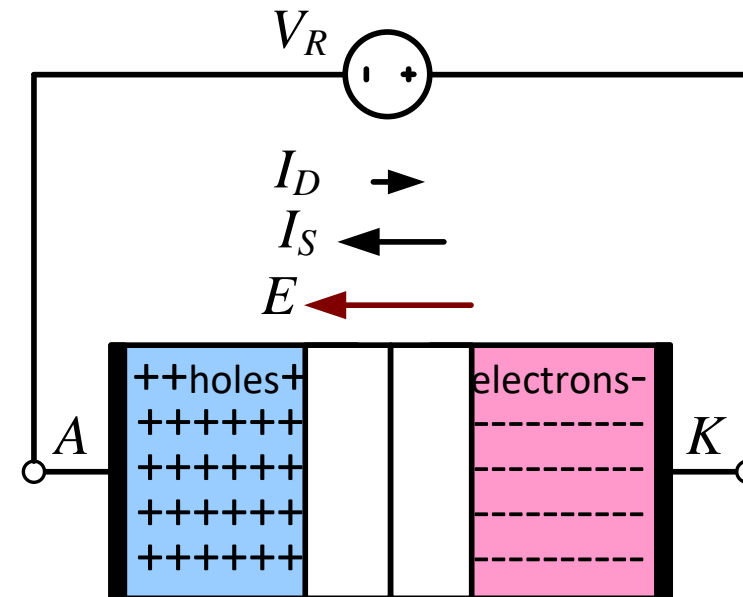
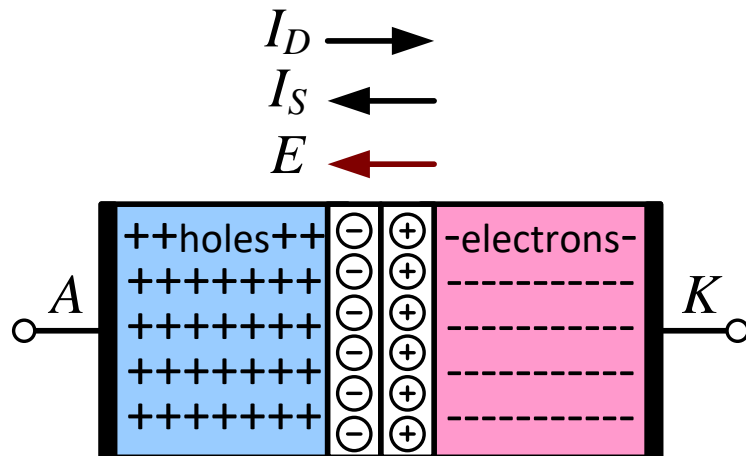
$$V_0 = V_T \ln \left( \frac{N_A N_D}{n_i^2} \right) \approx 2.3 V_T \log \left( \frac{N_A N_D}{n_i^2} \right) \approx 0.6 - 0.9V$$

- The barrier voltage ( $V_0$ ) limits carrier diffusion



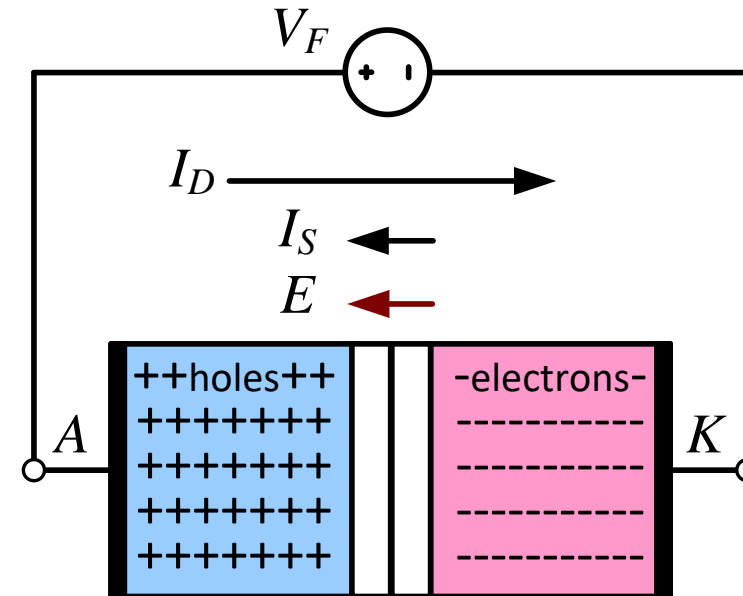
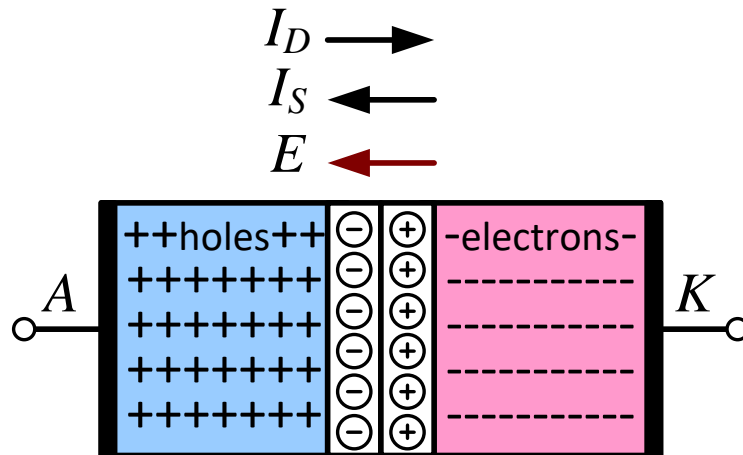
# PN Junction in Reverse (Rvr) Bias

- ❑ The applied reverse voltage increases diffusion barrier
  - Opposes diffusion current
- ❑ Electric field increases
  - But drift current almost unchanged: no carriers to accelerate
- ❑ Net current is very small  $\approx -I_S$
- ❑ Depletion width increases  $\rightarrow$  capacitance decreases
  - Capacitance at zero bias is larger



# PN Junction in Forward (Fwd) Bias

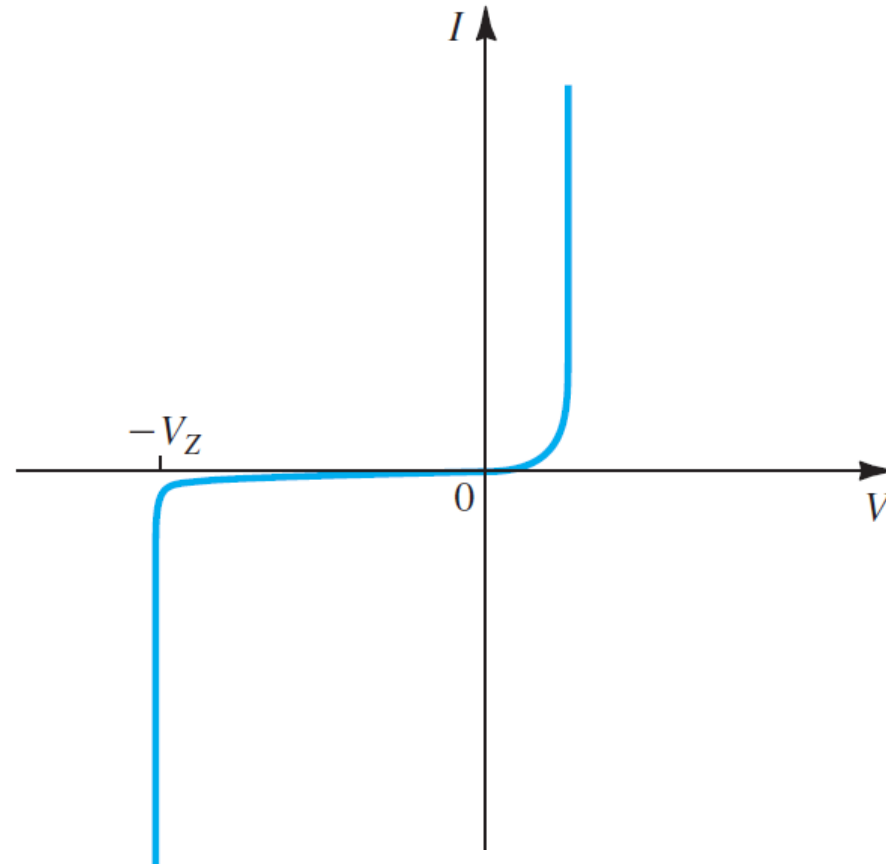
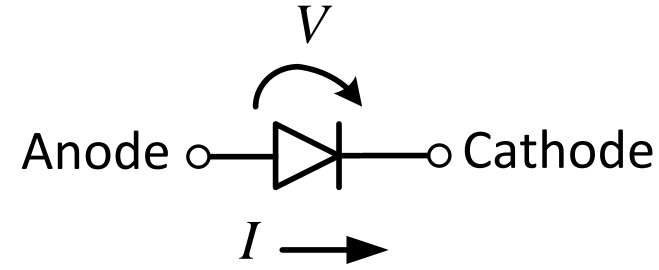
- ❑ The applied forward voltage decreases diffusion barrier
  - Dramatically increases diffusion current
- ❑ Net current is very high =  $I_D - I_S \approx I_D = I_S e^{\frac{V_F}{V_T}}$ 
  - Forward current exponentially increases with voltage across diode ( $V_F$ )
- ❑ Depletion width decreases





# PN Junction IV Characteristics

- ❑  $I = I_S(e^{\frac{V}{V_T}} - 1)$
- ❑ Forward: High diffusion current exponentially dependent on  $V = V_F$
- ❑ Reverse: Very small drift current almost independent of  $V = -V_R$
- ❑ Breakdown: Very high reverse current at LARGE reverse bias voltage



[Sedra/Smith, 2015]

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**Thank you!**

# References

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- ❑ A. Sedra and K. Smith, “Microelectronic Circuits,” Oxford University Press, 7<sup>th</sup> ed., 2015.
- ❑ B. Razavi, “Fundamentals of Microelectronics,” Wiley, 2<sup>nd</sup> ed., 2014.